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10/658,114INFORMATION DISCLOSURE STATEMENT
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APPLICANT
Bilyalov, et al.FILING DATE
September 8, 2003GROUP
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FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
TT	1	JP03-235371	1/14/92	Japan (abstract only)				X
TT	2	JP05-283723	2/3/94	Japah (abstract only)				X

EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)	
TT	3	Bilyalov, et al., "Porous silicon as an intermediate layer for thin-film solar cell", Solar Energy Materials and Solar Cells, Elsevier Science Publishers, Amsterdam, Vol. 65, No. 1-4, Jan. 2001, pp. 477-485.
	4	Jin, et al., "Transmission electron microscopy investigation of the crystallographic quality of silicon films grown epitaxially on porous silicon", Journal of Crystal Growth, North-Holland Publishing Co., Amsterdam, Vol. 212, No. 1-2, 2000, pp. 119-127.
	5	Chang, et al., "Study and Fabrication of Pin Photodiode by using ZnSe/Ps/Si Structure", IEEE Transactions on Electron Devices, IEEE Inc., New York, Vol. 47, No. 1, January 1, 2000, pp. 50-54.
	6	Rubino, et al., "Amorphous/porous heterojunction on thin microcrystalline silicon", Journal of Non-Crystalline Solids, North-Holland Publishing Co., Amsterdam, Vol. 266-269, May 2000, pp. 1044-1048.
	7	Yerokhov, et al., "Porous silicon in solar cell structures: a review of achievements and modern directions of further use", Renewable and Sustainable Energy Reviews, Elseviers Science, New York, Vol. 3, No. 4, December 1999, pp. 291-322.
	8	Palsule, et al., "Electrical and optical characterization of crystalline silicon/porous silicon heterojunctions", Solar Energy Materials and Solar Cells, Elsevier Science Publishers, Amsterdam, Vol. 46, No. 4, July 1, 1997, pp. 261-269.
	9	European Search Report for Application No. EP 03 44 7226 (mailed December 15, 2003).

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EXAMINER	/Thanh Truc Trinh/	DATE CONSIDERED (12/14/2006)
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